



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 4772

SERIAL NUMBER 10/691,108	FILING DATE 10/22/2003 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 10191/3399
-----------------------------	---------------------------------------	--------------	------------------------	--------------------------------------

APPLICANTS

Klaus Breitschwerdt, Filderstadt, GERMANY;

Bernd Kutsch, Konz, GERMANY;

Franz Laermer, Weil Der Stadt, GERMANY;

** CONTINUING DATA ***** *None LV*

** FOREIGN APPLICATIONS ***** *Yr/ u*
 GERMANY 102 49350.2 10/23/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 01/22/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY GERMANY	SHEETS DRAWING 9	TOTAL CLAIMS 5	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met: <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>LV</i>				

ADDRESS

26646
 KENYON & KENYON
 ONE BROADWAY
 NEW YORK, NY
 10004

TITLE

Device and method for anisotropic plasma etching of a substrate, particularly a silicon element

FILING FEE RECEIVED 986	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
-----------------------------------	---	--